

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Karl-Heinz SCHUSTER

Application No.: 10/700,315

Filed: October 31, 2003

For: Interferometer Apparatus and
Method of Processing a Substrate
Having an Optical Surface

Customer No.: 20350

Confirmation No. 5458

Examiner: Hwa S. Lee

Technology Center/Art Unit: 2877

**Response to Notice of Non-Compliant
Amendment and Corrected Amendment**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Non-Compliant Amendment (37 CFR 1.121)
dated April 17, 2007, counsel submits this corrected Amendment as follows:

Amendments to the Claims are reflected in the Listing of Claims which
begins on page 2 of this paper.

Remarks/Arguments begin on page 12 of this paper.